## Interference Searched



Application/Control No.

Applicant(s)/Patent Under Reexamination

10706429

SAFFRAN, MICHAEL D.

Examiner

Haney, Richale L

Art Unit 3765

| Class                            | SubClass                        | Date      |     | Examiner |
|----------------------------------|---------------------------------|-----------|-----|----------|
| See EAST .clm. search            |                                 | 9/20/2006 | RLH |          |
| U.S. Patent and Trademark Office | Patent and Trademark Office Par |           |     | :        |

## Search Notes



Application/Control No.

Applicant(s)/Patent Under Reexamination

10706429

SAFFRAN, MICHAEL D.

Examiner

Haney, Richale L

Art Unit 3765

| Notes                            | Date      | Examiner           |
|----------------------------------|-----------|--------------------|
| See EAST printout                | 9/20/2006 | RLH                |
| U.S. Patent and Trademark Office |           | Part of Paper No.: |

## Searched



Application/Control No.

Applicant(s)/Patent Under Reexamination

10706429

SAFFRAN, MICHAEL D.

Examiner

Haney, Richale L

Art Unit 3765

|     | Class | SubClass | Date      | Examiner |
|-----|-------|----------|-----------|----------|
| 2   |       | 209,423  | 9/20/2006 | RLH      |
| 381 |       | 71.6     | 9/20/2006 | RLH      |

|                                  | · · · · · · · · · · · · · · · · · · · |
|----------------------------------|---------------------------------------|
| U.S. Patent and Trademark Office | Part of Paper No.:                    |
| 1                                |                                       |